



1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jack Oon Chu et al.

Serial No.: 09/683,088

Filed: November 16, 2001

For: SINGLE REACTOR, MULTI-  
PRESSURE CHEMICAL  
VAPOR DEPOSITION FOR  
SEMICONDUCTOR  
DEVICES

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: Art Unit: 1765  
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: Examiner: Not yet assigned  
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: Atty Docket: 21806/0112  
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SUBMISSION OF FORMAL DRAWINGS

Commissioner for Patents  
Washington, D.C. 20231

Sir:

The undersigned attorney respectfully submits the following 3 sheets of formal drawings of Figs. 1-3 in the above-captioned application.

Respectfully submitted,

Patrick J. Wells

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